

Special Issue

MEMS for Aerospace Applications

Message from the Guest Editor

Aerospace is a quality-based industry that follows very strict rules with regards to safety of the equipment. These features did not make the aerospace a suitable candidate for aerospace industry. The heavy development of sensors used in the mass production of ground transportation vehicles provided some support towards the implementation of low-mass sensing devices in the aerospace industry. It is well known that the main concern of the aerospace industry is mass. Any safety-related equipment installed on an aircraft will add significant mass unless those systems are microsystems. Once the first inertial, pressure, temperature or flow sensors were implemented on prototypes, the concept of microsystems in the aerospace industry gained more interest. Thus, pressure and flow sensors that could be installed to feed data during flight missions from the LP or even HP compressor within the engine were developed. The major advantage of this technology was expanded into the cockpit, where most of the apparatus are screens connected to a computation unit, which yields the needed information in the classic format of a dial indicator.

Guest Editor

Prof. Dr. Ion Stiharu

Department of Mechanical and Industrial Engineering, Concordia University, 1455 de Maisonneuve Blvd. West, Montreal, QC H3G 1M8, Canada

Deadline for manuscript submissions

closed (1 April 2019)



Micromachines

an Open Access Journal
by MDPI

Impact Factor 3.0
CiteScore 6.0
Indexed in PubMed



mdpi.com/si/17532

Micromachines
Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland
Tel: +41 61 683 77 34
micromachines@mdpi.com

[mdpi.com/journal/
micromachines](https://mdpi.com/journal/micromachines)





Micromachines

an Open Access Journal
by MDPI

Impact Factor 3.0
CiteScore 6.0
Indexed in PubMed



[mdpi.com/journal/
micromachines](https://mdpi.com/journal/micromachines)



About the Journal

Message from the Editor-in-Chief

You are invited to contribute research articles or comprehensive reviews for consideration and publication in *Micromachines* (ISSN 2072-666X). *Micromachines* is published in the open access format. Research articles, reviews and other contents are released on the internet immediately after acceptance. The scientific community and the general public have unlimited free access to the content as soon as it is published. As an open access journal, *Micromachines* is supported by the authors or their institutes by payment of article processing charges (APC) for accepted papers. We are pleased to welcome you as our authors.

Author Benefits

High Visibility:

indexed within Scopus, SCIE (Web of Science), PubMed, PMC, Ei Compendex, dblp, and other databases.

Journal Rank:

JCR - Q2 (Instruments and Instrumentation) / CiteScore - Q1 (Mechanical Engineering)

Rapid Publication:

manuscripts are peer-reviewed and a first decision is provided to authors approximately 16.8 days after submission; acceptance to publication is undertaken in 1.9 days (median values for papers published in this journal in the second half of 2025).